



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Minoru KATAYAMA et al.

Application No.: 09/690,590

Filed: October 18, 2000

Confirmation No.: 2593

Group Art Unit: 2856

Examiner: M. Cygan

Docket No.: 107612

For: SURFACE TEXTURE MEASURING MACHINE, LEVELING DEVICE FOR  
SURFACE TEXTURE MEASURING MACHINE AND ORIENTATION-ADJUSTING  
METHOD OF WORKPIECE OF SURFACE TEXTURE MEASURING MACHINE

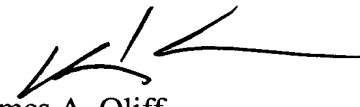
**LETTER TO THE OFFICIAL DRAFTSPERSON**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Please substitute the attached 1 sheet of formal drawings depicting Figures 17 and 18  
for the corresponding drawings filed with the application. The attached drawings have been  
corrected pursuant to Examiner's approval of drawing corrections of Paper No. 13.

Respectfully submitted,

  
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Date: November 5, 2002

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